## 505946872 03/03/2020

# **PATENT ASSIGNMENT COVER SHEET**

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

#### **CONVEYING PARTY DATA**

Name	<b>Execution Date</b>
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### **PROPERTY NUMBERS Total: 1**

Property Type	Number
Application Number:	16750364

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DATE SIGNED:	03/03/2020

**Total Attachments: 2** 

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PATENT 505946872 REEL: 051994 FRAME: 0705

Attorney Docket No.: 920 526

# DECLARATION (37 CFR 1.63) FOR UTILITY OR DESIGN APPLICATION USING AN APPLICATION DATA SHEET, AND ASSIGNMENT

Title of Invention: 発明の名称: VAPOR DEPOSITION MASK AND METHOD FOR MANUFACTURING SAME, VAPOR DEPOSITION MASK DEVICE AND METHOD FOR MANUFACTURING SAME, INTERMEDIATE, VAPOR DEPOSITION METHOD, AND METHOD FOR MANUFACTURING ORGANIC ELDISPLAY DEVICE

DISTERN DEVICE	
As the below named inventor, I hereby declare that:  This declaration is directed to:	私は、以下に記名された発明者として、ここに下記の 通り宣言する:
[ ] The attached application, or  [ X] United States application or PCT International Application Number 16/750,364 filed on January 23, 2020.  The above identified application was made or authorized to be made by me.  I believe that I am the original inventor or an original joint inventor of a claimed invention in the application.	本宣言は以下に対するものである:  [ ] 添付出願書または  [ ]の日に出願された米国 出願番号または PCT 国際出願番号 の出願書。  上記の特定の出願は私または私の承認によって行われたものである。  私は出願書において特許請求している発明の最初の発明者または最初の共同発明者であると信じている。
I hereby acknowledge that any willful false statement made in this declaration is punishable under 18 U.S.C. 1001 by fine or imprisonment of not more than five (5) years, or both.	私は本宣言における故意の虚偽の記載は米国法典第 18 編第 1001 条に基づき、罰金または五(5)年以下の懲役、もしくはその両方によって処罰されることがあることを承認する。
ASSIGNMENT: In consideration of the sum of one dollar (\$1.00) and other good and valuable consideration paid to each of the undersigned, the undersigned agree(s) to assign, and hereby does assign, transfer and set over to	譲渡証: 各々の署名人に対して支払われた総額1ドル (\$1.00) および他の適切な有価約因を考慮して、本 署名人(ら)は、
Name of Assignee: 譲受人の名前: Address of Assignee: 譲受人のアドレス:	DAI NIPPON PRINTING CO., LTD.  1-1, Ichigaya-kaga-cho 1-chome, Shinjuku-ku, Tokyo-to, Japan

(hereinafter designated as the Assignee) the entire right, title and interest for the United States, its territories, dependencies and possessions, in the invention, and all applications for patent and any Letters Patent which may be granted therefor for which the undersigned have executed an application for patent in the United States of America.

(以下、譲受人と称する)に対して、譲渡に同意し、本 発明および特許のための全ての出願、署名人がアメリ カ合衆国において特許出願を行い付与された全ての特 許証における、アメリカ合衆国ならびにその領土、属 領、財産のための全ての権利、所有権、および利権を 譲受人に移転および譲渡する。

Legal Name of Inventor/Assignor: 発明者/譲渡人の氏名 Inventor/Assignor (発明者/譲渡人):_ Date (日付): 「「そりいると、十	Chikao Henaga.	
Legal Name of Inventor/Assignor: 発明者/譲渡人の氏名 Inventor/Assignor (発明者/譲渡人): _ Date (日付):		
Legal Name of Inventor/Assignor: _ 発明者/譲渡人の氏名 Inventor/Assignor (発明者/譲渡人): _ Date(日付):		
Legal Name of Inventor/Assignor: _ 発明者/譲渡人の氏名 Inventor/Assignor (発明者/譲渡人): _ Date(日付): _		
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